

RECEIVED
CENTRAL FAX CENTER

NOV 18 2004

Docket No.: 2328-059

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	: : EXPEDITED PROCEDURE
Rajinder DHINDSA, et al.	: : Response under 37 CFR 1.116
U.S. Patent Application No. 10/032,279	: Confirmation No. 4056
Filed: December 31, 2001	: Group Art Unit: 1763
	: Examiner: ANNA M. CROWELL

For: **PLASMA PROCESSOR IN PLASMA CONFINEMENT REGION WITHIN A
VACUUM CHAMBER**AMENDMENT UNDER RULE 116Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

November 18, 2004

Sir:

This paper is submitted in reply to the Office Action mailed October 15, 2004, which was made Final. Applicants respectfully request that the following amendments as to form be entered to place this application in condition for allowance.

CERTIFICATION OF FACSIMILE TRANSMISSION
I HEREBY CERTIFY THAT THIS PAPER IS BEING FACSIMI-
LE TRANSMITTED TO THE PATENT AND TRADEMARK OFFICE
ON THE DATE SHOWN BELOW
ALICE L. WEAVER
TYPE OR PRINT NAME OF PERSON SIGNING CERTIFICATION
Alice Weaver 11/18/04
SIGNATURE DATE
(703) 872-9306
FACSIMILE NUMBER